

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLN. OF: OHTO et al.

FILED: December 30, 2003

FOR: ORGANIC INSULATING FILM, MANUFACTURING METHOD THEREOF, SEMICONDUCTOR DEVICE USING SUCH ORGANIC INSULATING FILM AND MANUFACTURING METHOD THEREOF

DOCKET: NEC NE03P181

MAIL STOP PATENT APPLICATION
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

In connection with the above-entitled matter, Applicants hereby attach U.S. Patent Office Form PTO-1449, including copies of the references listed therein, which were considered prior to the initial filing. The claims in the present application are believed to be patentably distinguished over these references.

This information disclosure statement is being made pursuant to the duty of disclosure imposed by law and formulated in 37 CFR 1.56(A). No representation is made that the information thus disclosed in fact constitutes prior art or that it is the closest prior art, inasmuch as 37 CFR 1.56(A) relies on a materiality concept which depends on subjectivity.

In the event there are any fee deficiencies or additional fees are payable, please charge them (or credit any overpayment) to our Deposit Account No. 08-1391.

Respectfully submitted,



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DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and no considered. Include copy of this form with next communication to applicant.